Search Notes

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/789,333	LEE ET AL.	
Examiner	Art Unit	
Hong C. Kim	2185	

SEARCHED					
Class	Subclass	Date	Examiner		
711	103	8/15/07	ish		
	159				
	170				
	109	U	d		
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INTERFERENCE SEARCHED						
Class	Subclass	Date	Examiner			
711	103	8/15/07	ish			
	159					
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
EAST	8/15/67	MA		
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